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			Application Number	10/539,649-Conf. #6622	
			Filing Date	June 15, 2005	
			First Named Inventor	Kazuhiko Oda	
			Art Unit	1775	
			Examiner Name	A. A. Turner	
Sheet	1	of	1	Attorney Docket Number	20239/0201924-US0


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<i>AK</i>	CA	Jung et al., "The Investigation of Thermal Effect on the Properties of Pulsed Laser Deposited Diamond-Like Carbon Films," <i>Thin Solid Films</i> , 332:103-108, 1998.	
<i>AK</i>	CB	Office Action in co-pending Japanese Application No. 2001-342218, issued by Japanese Patent Office, August 14, 2007, English translation of document.	

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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> ( Not for submission under 37 CFR 1.99)	Application Number		10539649	
	Filing Date		2005-06-15	
	First Named Inventor	Kazuhiko Oda		
	Art Unit	1775		
	Examiner Name	Not Yet Assigned		
	Attorney Docket Number	20239/0201924-US0		

4		4	2002322555	JP		2002-11-08	Kobe Steel Ltd		<input checked="" type="checkbox"/>
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	2	Diaz, et al., 1992. "Raman spectroscopy of carbon films grown by pulsed laser evaporation of graphite". Diamond and Related Materials 1: 824 - 827.	<input type="checkbox"/>

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( Not for submission under 37 CFR 1.99)

Application Number	10539649
Filing Date	2005-06-15
First Named Inventor	Kazuhiko Oda
Art Unit	1775
Examiner Name	Not Yet Assigned <i>A. Turner</i>
Attorney Docket Number	20239/0201924-US0

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<i>2</i>	2	02022458	JP		1990-01-25	Matsushita Electric Ind Co Ltd		<input checked="" type="checkbox"/>
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